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Attny. Docket No.: 2003-0395/N1085-90166

JAN 06 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application:	:	Group Art Unit: 2813
Yi-Lung Cheng et al.	:	
Serial Number: 10/728,215	:	Examiner: Laura M. Schillinger
	:	
Filed: December 4, 2003	:	Atty Docket No.: 2003-0395/N1085-90166
	:	
Title: Novel Method To Deposit Carbon Doped SiO₂ Films With Improved Film Quality	:	Date: January 6, 2006
	:	
	:	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

This paper is responsive to the non-final Office Action dated September 30, 2005. A petition for a one (1) month extension of time to extend the response due date to January 30, 2006 is included herewith. Kindly enter the following amendments:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.